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Substitute Form PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE					DOCKET NAA237	SN 10/573,942	SHEET	1 OF 1
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Information Disclosure Statement					Akinobu Sato, et al.			
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			U	S. PATENT	DOCUMENTS			
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Initial	No.	journal, serial, symposium, caulage, etc., Jute, page(s), volume-issue munker(s), publisher, city and/or country where published. Yamada, "Cluster ion beam process technology – 20 years of R&D history", Nuclear Instruments and Methods in Physics Research, B257, 2007, pp.632-638.						NO
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EXAMINER		4.51			DATE CONSIDERED			
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